



Docket No.: SON-1968  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Masakazu Muroyama, et al

Application No.: 09/739,739

Group Art Unit: 2882

Filed: December 20, 2000

Examiner: E. Gemmell

For: CATHODE FOR AN ELECTRON EMISSION  
DEVICE, COLD CATHODE FIELD EMISSION  
DEVICE AND METHOD FOR THE  
PRODUCTION THEREOF, AND COLD  
CATHODE FIELD EMISSION DISPLAY AND  
METHOD FOR THE PRODUCTION  
THEREOF HAVING A CARBON FILM  
SELECTIVE-GROWTH REGION (As  
Amended)

**AMENDMENT**

**Mail Stop Non-Fee Amendment**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated February 12, 2003 (Paper No. 8), please amend  
the above-identified U.S. patent application as follows:

**In the Title**

Please change the title of the invention from Electron Emission Device, Cold Cathode Field Emission Device And Method For The Production Thereof, And Cold Cathode Field Emission Display And Method For The Production Thereof, to Cathode For An Electron Emission Device, Cold Cathode Field Emission Device And Method For The Production Thereof, And Cold Cathode Field Emission Display And Method For The Production Thereof Having A Carbon Film Selective Growth Region